World Academy of Science, Engineering and Technology International Journal of Mechanical and Materials Engineering Vol:8, No:12, 2014

Microstructural Study of Mechanically Alloyed Powders and the Thin Films of Cufe Alloys

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Abstract : Polycrystalline CuFe thin film was prepared by thermal evaporation process (Physical vapor deposition), using the nanocrystalline CuFe powder obtained by mechanical alloying After 24 h of milling elemental powders. The microscopic study of nanocrystalline powder and the thin film of Cu70Fe30 binary alloy were examined using transmission electron microscopy (TEM) and scanning electron microscope (SEM). The cross-sectional TEM images showed that the obtained CuFe layer was polycrystalline film of about 20 nm thick and composed of grains of different size ranging from 4 nm to 18 nm.

Keywords: nanomaterials, thin films, TEM, SEM

Conference Title: ICMMSE 2014: International Conference on Mechanics, Materials Science and Engineering

Conference Location: Istanbul, Türkiye Conference Dates: December 22-23, 2014